



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

BIBDATASHEET

CONFIRMATION NO. 7853

Bib Data Sheet

SERIAL NUMBER 10/067,425	FILING DATE 02/04/2002 RULE	CLASS 438	GROUP ART UNIT 2829	ATTORNEY DOCKET NO. NL 010069
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Nicolaas Johannes Anthonius Van Veen, Eindhoven, NETHERLANDS;

 Marc Andre De Samber, Eindhoven, NETHERLANDS;
 Thomas Weiss, Hamburg, GERMANY;

S.B.G.

** CONTINUING DATA *****

NONE

S.B.G.

** FOREIGN APPLICATIONS *****

EUROPEAN PATENT OFFICE (EPO) 01200496.6 02/09/2001

S.B.G.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/01/2002

Foreign Priority claimed: 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY NETHERLANDS	SHEETS DRAWING 2	TOTAL CLAIMS 109	INDEPENDENT CLAIMS 1
Verified and Acknowledged	Examiner's Signature: <i>MD</i> Initials: <i>S.B.G.</i>				

ADDRESS

 24737
 PHILIPS INTELLECTUAL PROPERTY & STANDARDS
 P.O. BOX 3001
 BRIARCLIFF MANOR, NY
 10510

6/1/04
 Method of making a surface mountable semiconductor device
 TITLE USING A FLEXIBLE FILM AND A SEMICONDUCTOR DEVICE
~~Method of manufacturing a semiconductor device and a semiconductor device obtained by means of said method~~
 OBTAINED BY MEANS OF SAID METHOD

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
	RECEIVED	<input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)